

In RE application of T. HATTORI et al

Serial No.: 10/026,973

Group Art Unit: 1756

Filed: December 27, 2001

Examiner: S. ROSASCO

For: A PHOTOMASK, THE MANUFACTURING METHOD, A PATTERNING METHOD,
AND A SEMICONDUCTOR DEVICE MANUFACTURING METHODAssistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Transmitted herewith is an Amendment in the above-identified application.

- ☐ Small entity status of this application under 37 CFR 1.9 and 1.27 has been established by a verified statement previously submitted.
- ☐ A verified statement to establish small entity status under 37 CFR 1.9 and 1.27 is enclosed.
- ☒ No additional fee is required.

The fee has been calculated as shown below:

(COL. 1)	(COL. 2)	(COL. 3)
Claims Remaining After Amendment	Highest No. Previously Paid For	Present Extra
Total * 14	Minus ** 20	= 0
Indep. * 1	Minus *** 3	= 0
<input type="checkbox"/> First Presentation of Multiple Dependent Claims		

SMALL ENTITY	
Rate	Additional Fee
x 9	\$
x 42	\$
+ 140	\$
Total	\$

OTHER THAN A SMALL ENTITY	
Rate	Additional Fee
x 18	\$ 0
x 84	\$ 0
+ 280	\$ 0
Total	\$ 0

- * If the entry in Col. 1 is less than the entry in Col. 2, write '0' in Col. 3.
- ** If the 'Highest Number Previously Paid For' IN THIS SPACE is less than 20, write '20' in this space.
- *** If the 'Highest Number Previously Paid For' IN THIS SPACE is less than 3, write '3' in this space.
- The 'Highest Number Previously Paid For' (Total or Independent) is the highest number found from the equivalent box in Col. 1 of a prior Amendment or the number of claims originally filed.

- ☐ Please charge my Deposit Account No. 50-1417 in the amount of \$ _____.
- ☐ A check in the amount of \$ _____ is attached in payment of: _____.
- ☒ The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 50-1417.
- ☒ Any filing fees under 37 CFR 1.16 for the presentation of extra claims.
- ☒ Any patent application processing fees under 37 CFR 1.17.
- ☒ Any Extension of Time fees that are necessary, which are hereby requested if necessary.

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Date: August 25, 2004



T&A-109

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

T. HATTORI et al

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METHOD, AND A SEMICONDUCTOR DEVICE MANUFACTURING METHOD

REPLY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

August 25, 2004

Sir:

In reply to the Office Action mailed May 25, 2004, please
amend the above-identified application as follows.